



**ELECTRONIC COPY**

LG760543399  
Report verification at igi.org



December 27, 2025  
IGI Report Number **LG760543399**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **9.01 X 6.61 X 4.11 MM**  
**GRADING RESULTS**  
Carat Weight **1.54 CARAT**  
Color Grade **D**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

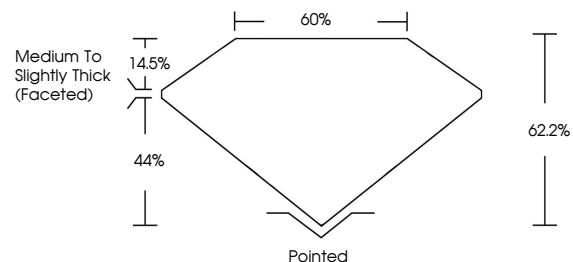
Carat Weight **1.54 CARAT**  
Color Grade **D**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG760543399**

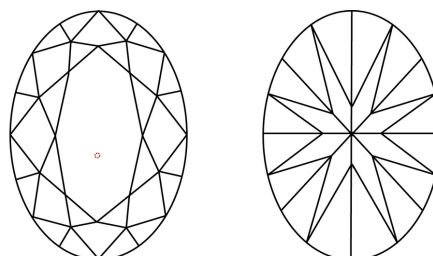
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

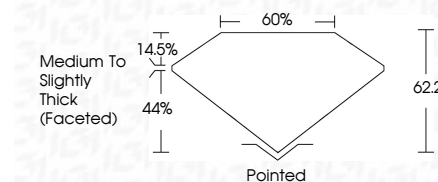
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



December 27, 2025  
IGI Report No LG760543399  
OVAL BRILLIANT  
9.01 X 6.61 X 4.11 MM  
1.54 CARAT  
Color Grade D  
Clarity Grade VVS 2  
Depth 62.2%  
Table 44%  
Girdle Medium to Slightly Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG760543399  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa